



Attorney Docket No. 0756-2412

3742

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CJ

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI

Serial No. 10/021,708

Filed: December 19, 2001

For: HEAT TREATMENT APPARATUS

AND METHOD OF

MANUFACTURING A

SEMICONDUCTOR DEVICE

) Group Art Unit: 3742

) Examiner: S. Fuqua

) CERTIFICATE OF MAILING

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RESPONSE TO ELECTION REQUIREMENT

Honorable Commissioner of Patents

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Alexandria, VA 22313-1450

Sir:

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TECHNOLOGY CENTER R3700

Further in response to the Official Action dated September 30, 2003, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 26 of this paper.